The measurement of the diameter change of a piezoelectric transducer cylinder with the white-light interferometry

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ABSTRACT

The measurement of the diameter change of a piezoelectric transducer (PZT) cylinder with the white-light interferometry is proposed and experimentally demonstrated. One arm of a Mach–Zehnder interferometer (MZI) is wrapped on the PZT cylinder, and the phase change of the interferogram of the MZI is used to determine the diameter change when a DC voltage is applied on the PZT cylinder. The Fourier transform white-light interferometry is used for recovering the phase change of the interferometer. The experimental results show that the diameter change resolution of 0.8 nm for the PZT cylinder with diameter of 40 mm is achieved.

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1. Introduction

Piezoelectric materials have a natural property which is the ability of interaction between the electrical and mechanical states. They have attracted much attention due to their wide applications in sensing and actuating systems. Diverse styles of piezoelectric transducers have been developed with different structures such as plate type, rod type, ring type, and cylinder type.

Piezoelectric cylinders are simple in construction than flat types and can easily deflect in all directions. They offer flexibility to operate under harsh condition such as high vacuum and high temperature. They are used in a wide range of applications such as atomic force microscopy (AFM) [1,2], scanning tunneling microscopes (STM) [3,4], optical fiber switch [5,6], optical fiber modulators [7], voltage sensors [8], Gyroscope [9], ultrasonic applications [10] and in ink jet printers [11].

Different methods are available for measuring piezoelectric transducer (PZT) coefficients: direct measurements of stress-induced charge [12], laser interferometers [13], laser scanning vibrometers [14], and piezoelectric force microscopes, etc. [15]. Laser interferometry methods are based on measuring the displacement deflection of the sample after an applied voltage. They have been established as popular and reliable technique for the measurement of piezoelectric coefficients $d_{31}$ and $d_{33}$ [16]. The displacement can be measured by a single-beam laser interferometer [17], where a Michelson interferometer is used. The reference arm length of the interferometer will change due to the piezoelectric deflection. This configuration has difficulty in separating the movement of the substrate from the dilatation of the sample. Double-beam interferometer was used to suppress the influence of the substrate movement [18,19]. To improve the measurement reliability and accuracy, other methods were proposed, such as scanning-modulated interferometer [20], and a Mach–Zehnder type heterodyne interferometer [21]. The crucial condition in these methods is the high resolution of an interferometer, which should be in the range of nanometer units [22]. Since the expansion of the PZT is small, the measurement is very sensitive to any small vibrations. Hence these techniques usually require a very quiet operation environment [23].

The white-light interferometry (WLI) is an attractive technique that is used for absolute measurements [24] and the measurement of the shape of objects [25], it allows the increase in the system operating range to overcome the fundamental problem that arises in conventional laser interferometry [26], and high resolution and dynamic range may be achieved [27].

In this paper, we present a technique for the PZT cylinder measurement by using the WLI. A PZT cylinder is wrapped by an arm of a MZI. We obtain the white-light interferogram when a DC voltage is applied between the faces of a PZT. The Fourier transform WLI is used for recovering the optical path difference (OPD) of the MZI [28]. Experimental measurements for diameter changes of a PZT cylinder at different driving voltages have been carried out, and experimental results show that the technique possesses high accuracy and high reliability.
2. Operation principle

The experimental setup for measuring the diameter change of the PZT cylinder is shown in Fig. 1. The light source is an amplified spontaneous emission (ASE) source with the wavelengths covering 1525–1565 nm, and the output power of 20 mW. Two fiber optic 3 dB couplers are used for splitting and recombining the light. The broad-band ASE light is divided into two equal power signals through the first coupler, one goes to the reference arm, and another one goes to the sensing arm. The reference light and the sensing light recombine at the second coupler.

The sensing arm is circled on a PZT cylinder P-81 (from Heng Sheng Acoustics Electron Apparatus Company) with the size of φ40 × φ35 × 30 mm for outside diameter, inner diameter and height respectively. A photograph of the PZT is shown in Fig. 2. A regulated DC source (NY1303A) is used with a voltage range of 0–30 V and a voltage resolution of 1% to drive the PZT cylinder.

The output of the MZI is interrogated by using a CCD based optical spectrum analyzer (OSA) (BaySpec FBGA-F-1525-1565) with the resolution of 0.1 nm. The OPD of the MZI must be smaller than the coherence length determined by the resolution of the OSA, otherwise we cannot detect the interferogram. The OPD to be smaller than the coherence length determined by the resolution of the optical spectrum analyzer (OSA) (BaySpec FBGA-F-1525-1565) with the size of φ40 × φ35 × 30 mm for outside diameter, inner diameter and height respectively. A photograph of the PZT is shown in Fig. 2. A regulated DC source (NY1303A) is used with a voltage range of 0–30 V and a voltage resolution of 1% to drive the PZT cylinder.

The OPD of the MZI can be calculated when the phase is obtained by using Fourier transform WLI. However, when we scan the wavelength from λ1 to λ2, we obtain a phase change. So the OPD is obtained from the following equation:

\[ OPD = \frac{\lambda_1 \cdot \Delta\phi}{2\pi \cdot (\lambda_2 - \lambda_1)} \]

Thus, the diameter change of the PZT can be calculated from the following equation:

\[ \Delta D = \frac{\Delta OPD}{\pi \cdot k} \]

where \( \Delta OPD \) is the change of the OPD due to an applied voltage, \( k \) is the number of fiber turns wrapped the PZT.

Therefore, the strain coefficient \( d_{31} \) can be estimated by the following equation [30]:

\[ d_{31} = \frac{\Delta D \cdot t}{ID \cdot V} \]

where \( \Delta D \) is the diameter change of the PZT, \( ID \) is the internal cylinder diameter, \( V \) is the applied voltage, and \( t \) is the wall thickness.

3. Experiment

In this experiment, the core and cladding diameters of the fiber are 9 μm and 125 μm respectively, and a fiber length of 9 m was used as one arm of the MZI. The PZT cylinder (P-81) with strain coefficient \( d_{31} = 98 \text{ pm/V} \) and an external diameter of 40 mm was wrapped by 5 m of fiber and the number of fiber turns is 40 turns. In order to protect the measured sample against vibrations, a quiet operational environment is needed.

When the wavelength is scanned from 1525 nm to 1560 nm, the interference spectrum can be observed at the OSA by adjusting the OPD to be smaller than the coherence length determined by the resolution of the OSA. The optical spectrum of the MZI with an applied voltage of 0 V is shown in Fig. 3.

When the voltage is applied on the PZT cylinder, the interference fringes suffer a phase shift. It can be seen that the optical spectrum is red-shifted to a higher wavelength region, as shown in Fig. 4.

The OPD can be calculated by using Fourier transform WLI. Firstly the optical spectrum is Fourier transformed. The main frequency component is filtered and inverse Fourier transformed. Then we calculate a complex logarithm of the product. The phase
change of the fringe signal, which is caused by scanning wavelength, can be obtained from the imaginary part of the complex logarithm. Thus, the absolute OPD can be calculated by using the phase change [31].

The Fourier spectrum is shown in Fig. 5. The spectrum was filtered and inverse Fourier transformed, as shown in Fig. 6. The interferometric phase changes is shown in Fig. 7. When the wavelength is scanned from 1525 nm to 1560 nm, the phase change is 113.09 rad and the OPD is calculated to be 1241.21 μm for an applied voltage of 0 V.

For an applied voltage of 25 V, the measured OPD is 1245.68 μm. Therefore, the change of the OPD can be calculated. Using Eqs. (3) and (4), the diameter change of the PZT cylinder and the strain coefficient $d_{31}$ are 0.035 μm and 100 pm/V, respectively, which is agreed to the strain coefficient provided by the manufacturer of the PZT.

Fig. 8 shows the measured OPD change for various applied voltages from 0 V to 25 V by an increment step of 5 V. A hysteresis cycle can be observed, the maximum and minimum OPD changes were found to be 1245.68 μm and 1241.21 μm at 25 V and 0 V, respectively. It can be seen that the value of the OPD decreases significantly from their value at high DC bias after the DC bias is removed.

In order to test the stability of the system, we measured the OPD 30 times at an applied voltage of 29 V. The measured results are distributed between 1246.663 and 1246.86 μm, as shown in Fig. 9. The fluctuation of the measurement results is 0.1 μm which shows that the stability of the system is well. For a PZT cylinder wrapped by a fiber length of 5 m, the resolution for the measurement of diameter change of the PZT cylinder that can be achieved is 0.8 nm. In fact; the stability can be significantly increased by doing an average calculation, to reduce any environmental effect.

The main reasons of errors in the measurement of diameter change are the resolution of the optical spectrum analyzer and the sensitivity to any external noises and environmental fluctuations.

4. Conclusion

In conclusion, we have presented a white-light interferometric method for the measurement of the diameter change of a PZT cylinder. The output of the MZI is interrogated by using an OSA, and the phase change of the interference spectrum during the applied voltage was used for the determination of the PZT diameter change.
The proposed method possesses the abilities to provide wide dynamic measurement range, low cost without other additional components, and offers advantage of easier fabrication. However, it requires a very quiet working environment. A resolution of up to 0.8 nm is achieved in our experiment. Thus the technique appears to have potential applications such as optical phase modulator, fiber stretching, and deformation measurement.

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